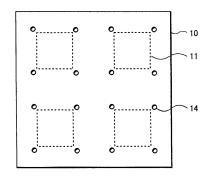
FIG.1A



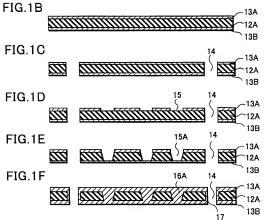
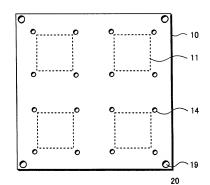


FIG.2A







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-13C

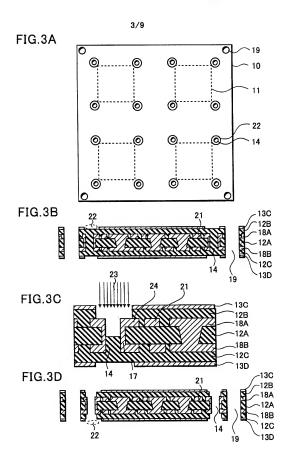
13C

FIG.2C

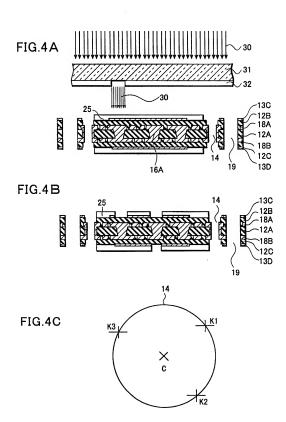


FIG.2D





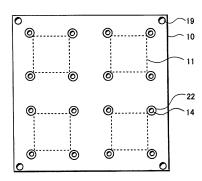
F1040898US00

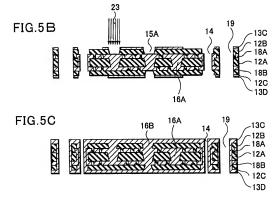


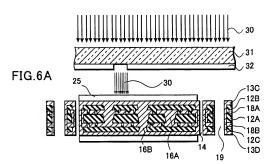
MULTILAYER SUBSTRATE MANUFACTURING METHOD

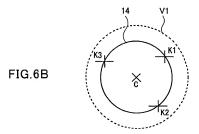
F1040898US00

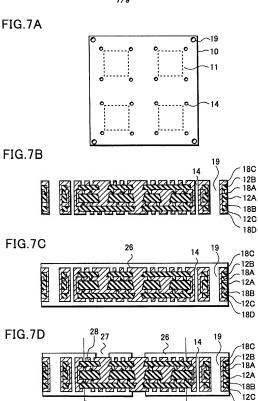
FIG.5A











-18D

FIG.8A

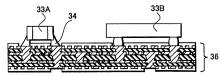
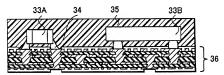


FIG.8B



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FIG.9A



FIG.9B

